

DOCKET NO: 273117US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
YASUAKI YOKOYAMA, ET AL. : EXAMINER: SHEVIN, MARK L.
SERIAL NO: 10/542,358 :
FILED: JULY 14, 2005 : GROUP ART UNIT: 1793
FOR: COMPOSITION FOR FORMING :
SILICON-ALUMINUM FILM, SILICON-
ALUMINUM FILM AND METHOD FOR
FORMING THE SAME

RESPONSE TO OFFICIAL ACTION DATED SEPTEMBER 23, 2008

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated September 23, 2008, please amend the above-identified application as follows:

Remarks/Arguments begin on page 2 of this paper.